10.1588659 **AP20** Rec'd PCT/PTO 07 AUG 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q96380

Hiroaki YANAGITA, et al.

Appln. No.: National Stage of PCT/JP2005/001596

Confirmation No.: Not yet assigned Group Art Unit: Not yet assigned

Filed: August 7, 2006 Examiner: Not yet assigned

For: SEMICONDUCTOR MATERIAL AND SEMICONDUCTOR DEVICE USING THE

SAME

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicants hereby notify the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after filing a request for continued examination (RCE) under §1.114, and therefore, no Statement under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

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INFORMATION DISCLOSURE STATEMENT

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U.S. Appln. No.: National Stage of PCT/JP2005/001596

Attorney Docket No. Q93680

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3)

for foreign language documents, Applicants encloses herewith a copy of a Communication

from a foreign patent office in a counterpart application citing such documents (International

Search Report for PCT/JP2005/001596 dated April 26, 2005), together with an English-

language version (if not already included) of at least that portion of the Communication

indicating the degree of relevance found by the foreign patent office.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicants do

not waive any right to take any action that would be appropriate to antedate or otherwise

remove any listed document as a competent reference against the claims of the present

application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

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CUSTOMER NUMBER

Date: August 7, 2006

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MODIFIED PTO/SB/08 A & B (08-03)

				Complete if Known		
Substitute for Form 1449 A & B/PTO				Application Number	Najoral State 05 8 6 5 9	
INFORMATION DISCLOSURE			SURE	Confirmation Number	Not yet assigned	
STATEMENT BY APPLICANT (use as many sheets as necessary)				Filing Date	August 7, 2006	
				First Named Inventor	Hiroaki YANAGITA et al.	
				Art Unit	Not yet assigned	
				Examiner Name	Not yet assigned	
Sheet	1	of	1	Attorney Docket Number	Q96380	

U.S. PATENT DOCUMENTS							
Examiner Cite Initials* No.1	Cita	Document	Number	Publication Date			
		Number	Number Kind Code ² (if known)		Name of Patentee or Applicant of Cited Docum		
		US					
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FOREIGN PATENT DOCUMENTS							
Examiner Cite Initials* No.	Foreign Patent Document			Publication Date	Name of Patentee or		
	_	Country Code ³	Number⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
		JP	2003-137700	Α	05-14-2003	NIKKO MATERIALS CO., LTD.	Abstract
		JР	2001-226200	A	08-21-2001	JAPAN SCIENCE AND TECHNOLOGY CORP.	Abstract
		JP	2002-289917	Α	10-04-2002	SHARP KK	Abstract
		JP	2004-043656	A	02-12-2004	JAPAN SCIENCE & TECH CORP. and NAT. INST. OF ADV. IND. & TECHNOL.	Abstract
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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶		
		MASAFUMI YAMAGUCHI et al., "Behavior of Copper Impurity in ZnSe", Japanese Journal of Applied Physics, Vol. 17, No. 2, pp. 335-340 (2 February 1978)			

Examiner Signature Date Considered			
	Examiner Signature	Date Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.